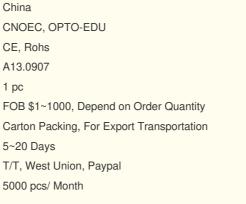
Research LWD Metallographic Microscope With Quarduple Nosepiece CE A13.0907

Basic Information

- Place of Origin:
- Brand Name:
- Certification:
- Model Number:
- Minimum Order Quantity:
- Price:
- Packaging Details:
- Delivery Time:
- Payment Terms:
- Supply Ability:





Product Specification

- Application:
- Certification:

Drawtube:

CE, Rohs

- Magnification:
- Theory:
- Nosepiece:
- Highlight:

Research, Metallurgical

Binocular

- 50X 500X
 - Metallurgical Optical Microscope
 - Quarduple Nosepiece
 - reflected light microscope, halogen lamp microscope



Description:

A13.0907 Metallurgical Microscope, with plan achromatic optics and Epi Kohler illumination system and anti-reflective structure in the epiillumination system, can make the image clarity better contrast of field of view, and effectively prevent interference by stray light. It is widely used in teaching and research metallographic analysis, semiconductor silicon wafer inspection, geology mineral analysis, precision engineering surveying fields.

- --Color Corrected Infinity Optical System, Better Image and Higher Resolution
- --Stable and Reliable Operatiing Mechanism Provide Clearer Image and Easier Operate
- --Modular Microscope Body with a New Ergonomic Design, Structural Symmetry Can Use with Many Accessories
- --Professional Infinity Plan Achromatic LWD metallurgical Objective, No Cover Glass Design
- --Reflected Illuminator with Iris Diaphragm and Centerable Field Diaphragm
- --90~240V Voltage, 12V50W Halogen Bulb

Specifications:

A13.0907 M	etallurgical Microscope	A AT B BT	
Head	Compensation Free Binocular Head, 30° Inclinded, 360° Rotatable,	0 0	
	Interpupillary Distance 54~75mm, Diopter Adjustable		
	Compensation Free Trinocular Head, 45° Inclinded, 360° Rotatable,	0 0	
	Interpupillary Distance 54~75mm, Diopter Adjustable		
Eyepiece	High Eyepoint Plan PL10x/18mm,		
Objective	Long Working Distance Plan Metallurgical Achromatic	LMPL5X/0.15	
		LMPL10X/0.3	
	Long Working Distance Plan Metallurgical Achromatic, Semi-APO	LMPL50X/0.6	
Nosepiece	Quarduple Nosepiece		
Stage	Double Working Stage, Size 140*132mm, Moving Range 50*76mm,		
	Moving Precision 0.1mm		
	Metal Plate 180*145mm for Large Object	0 0	
	Metal Plate 90*50mm	0 0	
Focusing	Low Position Coaxial Coarse & Fine Focusing, Fine Focusing		
	Precision 0.002mm, with Tension Adjustment and Up-limited Safty Stop		
Condenser	Abbe Condenser N.A.1.25, with Iris Diaphragm, with Filter Holder	0 0	
Filter	Green Filter, Dia.45mm		
Illumination	Reflect Illumination, with View Field Diaphragm, with Iris Diaphragm,		
	Center Adjustable, 6V30W Halogen, Brightness Control		
	Transmit Illumination, 6V30W Halogen,	0 0	
Power	90-240V Wide Range Power Supply		
A13.0907 M	etallurgical Microscope Optional Accessories		
Eyepiece	Wide Field Eyepiece WF15x/13mm	A51.0902-1513	
	Wide Field Eyepiece WF20x/10mm	A51.0902-2010	
	Wide Field Eyepiece WF15x/13mm with Retical	A51.0905-1513R	
	Wide Field Eyepiece WF20x/10mm with Retical	A51.0905-2010R	
	High Eyepoint Plan PL10x/18mm, with Cross PL10x18	A51.0905-1018R	
Objective	Long Working Distance Plan Metallurgical AchromaticLMPL20X/0.4	A5M.0934-20	
	Long Working Distance Plan Metallurgical Achromatic,Semi-APO LMPL100X/0.8	A5M.0934-100	
Filter	Green,Dia.45mm	A56.0935-XJZB	
	Yellow, Dia.45mm	A56.0935-XJZY	
	Netural,Dia.45mm	A56.0935-XJZF	
Adapter	1.0x C-Mount	A55.0925-10	
	0.5x C-Mount, for 1/2" CCD	A55.0925-50	
Adapter	0.35x C-Mount, for 1/3" CCD	A55.0925-35	
Adapter	0.35x C-Mount, for 1/3" CCD Digital Camera Adapter with Photo Eyepiece	A55.0925-35 A55.0910	

